



Docket No.: S8810.0003/P003  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Masashi Kawasaki et al.

Application No.: 10/588,283

Confirmation No.: N/A

Filed: August 4, 2006

Art Unit: Not Yet Assigned

For: METHOD OF MANUFACTURING THIN  
FILM, METHOD OF MANUFACTURING p-  
TYPE ZINC OXIDE THIN FILM AND  
SEMICONDUCTOR DEVICE

Examiner: Not Yet Assigned

**FIRST PRELIMINARY AMENDMENT**

MS Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

**INTRODUCTORY COMMENTS**

Prior to examination on the merits, please amend the above-identified U.S. patent application as follows:

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 3 of this paper.

**Remarks** begin on page 5 of this paper.